



#22/ Jms  
9/12/03  
Attorney Docket SEP 11 2003

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
)  
Murakami et al. )  
)  
Serial No.: 09/516,082 )  
)  
Filed: March 1, 2000 )  
)  
For: Semiconductor Device Comprising )  
A Thin Film Transistor Comprising )  
A Semiconductor Thin Film And )  
Method of Manufacturing The Same )  
)  
Art Unit: 2815 )  
)  
Examiner: E. Lee )

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

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September 11, 2003

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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace

Signature

9/11/03

Date

**AMENDMENT D**

Sir:

In response to the Office Action of June 11, 2003, please amend the above-identified  
application as follows:

RECEIVED  
SEP 17 2003  
TECHNOLOGY CENTER 2800